

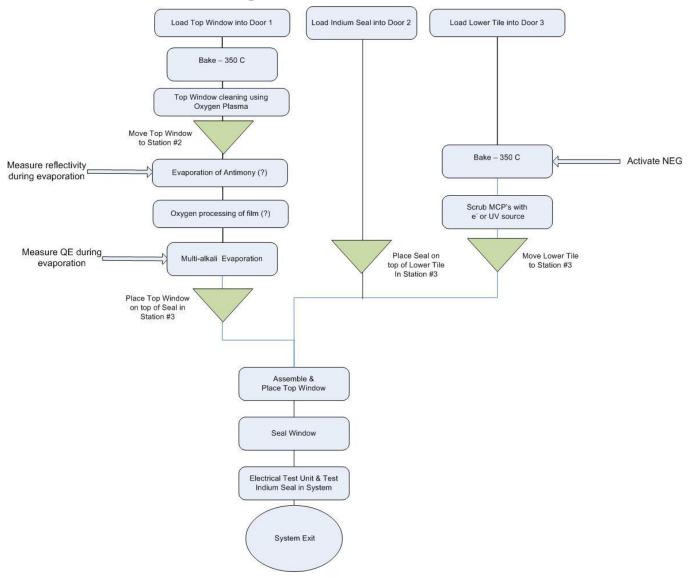
# Single Tile Process System - Process and sample movement description

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This is a summery of a simplified Tile production machine for the LAPPD Project



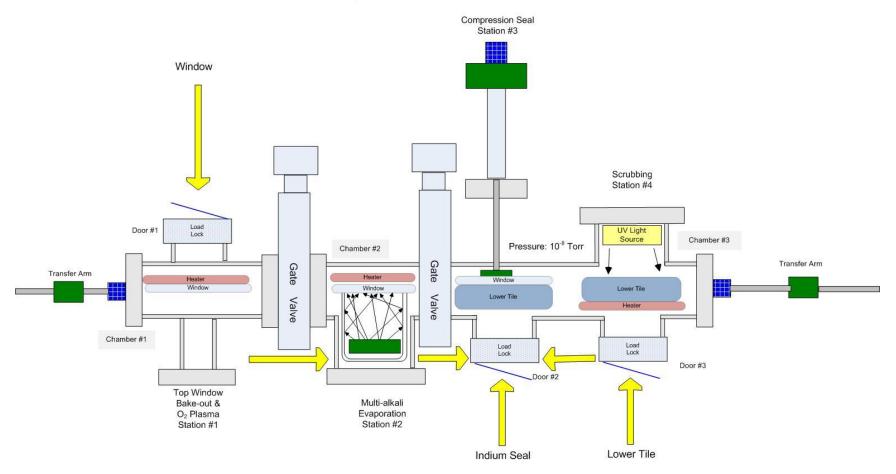
## **Material Processing Flow Chart**



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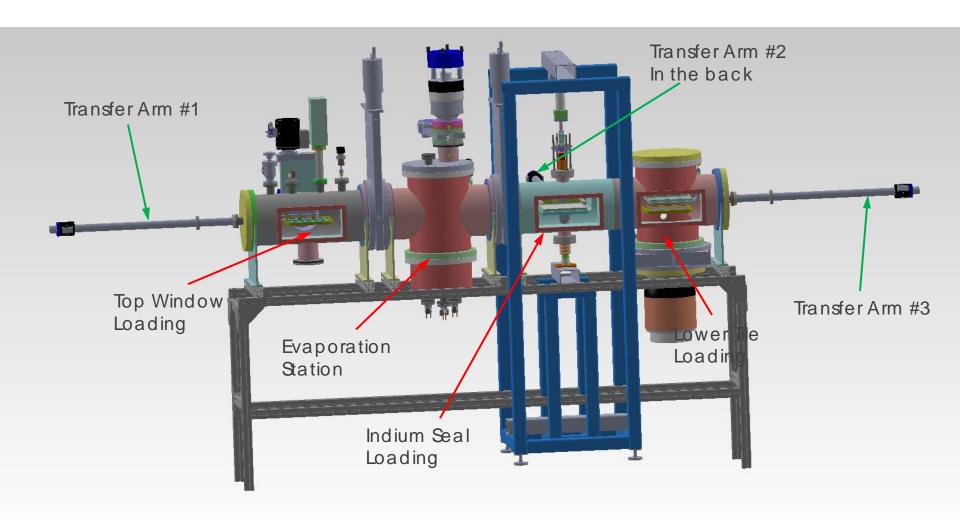
## Simplified Single Tile Production System

### Single Tile Production Machine





## Single Tile System



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### **Transfer Arms Movement**



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D. Walters

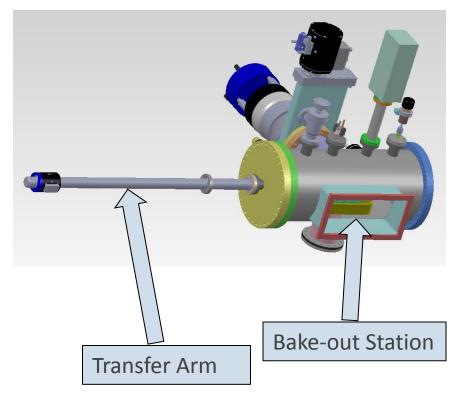
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## Chamber #1 --Station #1 - Top Window loading and bake-out station

- Functions
  - 1. Entry point of the Top Window
  - 2. Vacuum bake of the window
  - 3. Perform oxygen plasma treatment to window
    - 1. Control oxygen with the use of a MFC
    - 2. Throttle the pumping speed through the use of a bypass valve will be used to stabilize the process pressure.
- Sample Movement (using Transfer Arm #1)
  - 1. Operator manually inserts Top Window onto platen
  - 2. After processing, the transfer arm lifts the Top Window off the platen (~ 1 inch vertical)
  - 3. Transfer arm moves 28 (?) inches horizontally to Station #2
  - 4. Transfer arm lowers the Top Window onto the platen.
  - 5. Transfer arm retracts to Station #1 during the multi alkali evaporation
- 3. Total travel for Transfer Arm #1 is 72 inches 5 lbs. load without spatula weight.



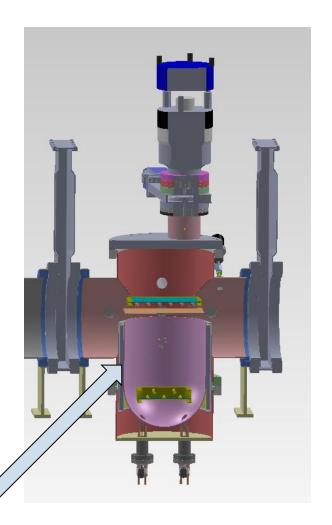
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## Chamber #2 - Center chamber --Station #2 - Multi alkali evaporation

#### 1. Functions

- 1. Station #2
  - 1. Multi Alkali will be evaporated onto the bottom face of the Top Window.
  - 2. Top Window can be electrically biased so the an in-situ quantum efficiency measurement can take place.
- 2. Sample Movement (using Transfer Arm #1)
  - 1. After processing, the transfer arm lifts the Top Window off the platen (~ 1 inch vertical)
  - 2. Transfer arm moves the top window horizontally to Station #3
  - 3. Transfer arm lowers the Top Window onto the lower tile assembly
  - Transfer arm retracts to get out of the way during the sealing process

Evaporator mounted on flange

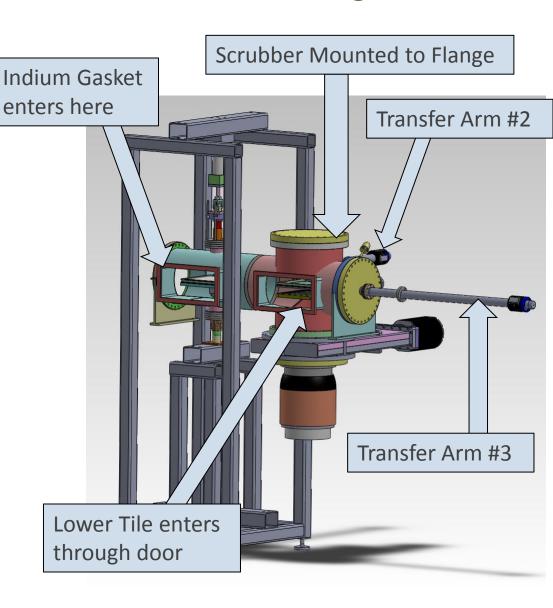


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### Chamber #3 Station #3 - Station #4 Scrubbing Station

#### 1. Functions

- 1. Lower Tile entry port
- 2. Vacuum bake of Lower Tile
- 3. Activation of NEG Pump
- 4. As necessary UV or electron scrubbing of MCP stack
  - 1. The scrubber will be above the Lower Tile and it will be mounted facing down.
  - 2. Scrubbing will be monitored by measuring the current on the Lower Tile anodes as electrons strike the MCP stack.
- 2. Sample Movement (using Transfer Arm #3)
  - Operator manually inserts Lower Tile onto Platen
  - 2. Transfer arm lifts Lower Tile (~ 1 inch)
  - 3. Transfer arm travels horizontally 36 inches
  - 4. Transfer arm lowers Lower Tile onto lower jaw of the Sealing Station
- Total travel of 42 inches load of 8 lbs. without spatula

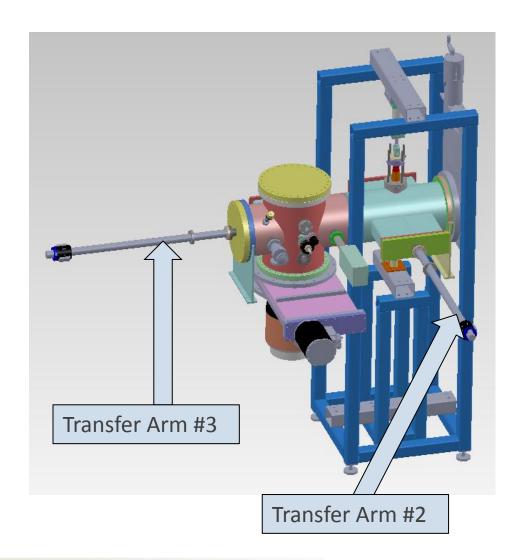


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### Chamber #3 Station #3 - Sealing station

#### 1. Station #3

- This will re-use the hydraulic cylinder and controls that was used for the smaller parts.
- 2. Assembling the Lower Tile, indium seal, and the Top Window onto the lower jaw of the Sealer initiates the sealing process
- 3. Hydraulic pressures will have the ability to me monitored remotely.
- 2. Sample Movement (using Transfer Arms #1 & #2 & #3)
  - 1. Transfer arm #3 will bring in the Lower Tile
  - Transfer arm #2 will lower the indium seal onto the tops of the sidewall of the Lower Tile .
  - 3. Transfer arm #2 will retract away from the assembly
  - 4. Transfer arm #1 will bring in the Top Window from Station #2 and locate it over the indium seal
- 3. Total travel for transfer arm #2 is 24 inches. With load of 1 lbs. without seal holding spatula.

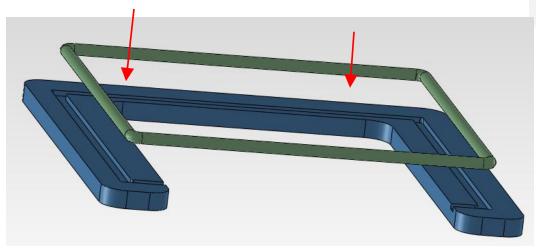


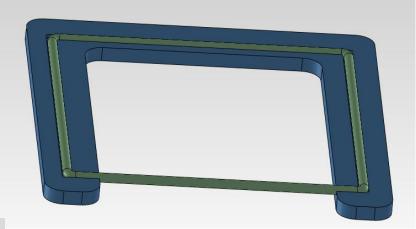
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## Transfer arm #2 - Loading the indium seal into the system

Step #1 The spatula is extended out through Door #2 to load the indium seal.

Step #2 The soft indium seal is placed into the groove in the spatula.

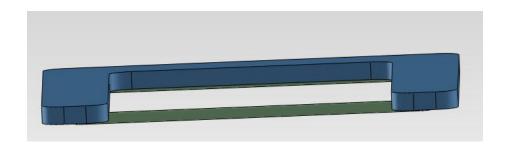




Step #3 The clasps that hold the seal in place are latched.
Step #4 The spatula is rotated 180 degrees and then retracted all the way into the system.

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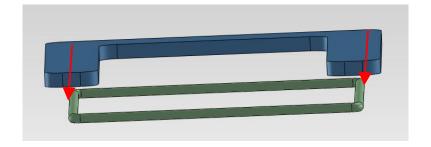
## Transfer arm #2 - Placing the indium seal on top of the Lower Tile assembly.

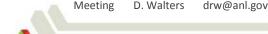


Step #5 Once the Lower Tile assembly has been placed on the lower jaw of the compression station then the seal is placed.

Step #6 The spatula is moved forward over the Lower Tile and is lined up to its edge within ± .02 inches.

Step #7 Open the clasps and place the seal Step #8 The spatula is retracted back out of the so the Top Window can then be placed.





3/13/2012